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Amendment Under 37 C.F.R. §1.116
Art Unit 2615, Expedited Procedure

In re Application of:

YOSHIHIRO ISHIDA ET AL.

Application No.: 09/164,624

Filed: October 1, 1998

For: MONITORING SYSTEM
APPARATUS AND
PROCESSING METHOD
(As Amended)

Examiner: Lin Ye

Art Unit: 2615

December 20, 2005

Mail Stop: AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL ACTION

Sir:

In response to the Office Action dated September 22, 2005, please amend the above-identified application as follows. The specification changes begin on page 2, amendments to the claims are reflected in the listing beginning on page 4, and the Remarks begin on page 10.

PER
RCE
dated
7/31/06
mg
8/2/06